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UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Yeong-Kwan KIM, et al.

Art Unit: 2822

Serial No. 09/902,607

Examiner: Toniae M. THOMAS

Filed: July 12, 2001

Confirmation No. 1299

For: SEMICONDUCTOR DEVICE HAVING
THIN FILM FORMED BY ATOMIC LAYER
DEPOSITION AND METHOD FOR
FABRICATING THE SAME

Attorney Docket No. 249/258

AMENDMENT UNDER 37 C.F.R. § 1.111

Commissioner for Patents
United States Patent and Trademark Office
P.O. Box 1450
Alexandria, VA 22313-1450

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REC'D

Sir:

INTRODUCTORY COMMENTS

In response to the Office Action mailed November 5, 2003, please amend the application identified above as follows: